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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2815
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63936

Makoto NONAKA

Appln. No.: 09/823,752

Group Art Unit: 2815

Confirmation No.: 9106

Examiner: George C. ECKERT II

Filed: April 03, 2001

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 6, 2003, please consider the remarks as submitted herewith on the accompanying pages.

REMARKS

Applicant thanks the Examiner for considering the references cited with the Information Disclosure Statement filed April 21, 2003.

Status of the Application

Claims 3, 8-16, 24-26 and 30 are all the claims pending in the Application. Only claims 3 and 24-26 have been rejected.

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